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LIST OF REFERENCES CITED BY APPLICANT(S)
(Use several sheets if necessary)

July 21, 2005

ATTY DOCKET NO. 00862.022311.1	APPLICATION NO. 10/678,146
APPLICANT Kazutaka YANAGITA et al.	
FILING DATE October 6, 2003	GROUP 2822

U.S. PATENT DOCUMENTS

*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT

OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)

PH		**Nagano, K, *et al.* "Oxidized Porous Silicon and It's Application," Semiconductor Research Lab, Matsushita Electric Industrial Co., Ltd., IEICE Technical Report, vol. 79, SSD79-9549 (1979).**

EXAMINER	DATE CONSIDERED
[signature]	10-12-05

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.